



# Information Disclosure Citation

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Application Number

10/536,829

Applicant

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Filing Date

May 27, 2005

Group Art Unit

1795

## U. S. Patent Documents

Examiner Initial	Ref	Document Number	Date	Name	Class	Subclass	Filing Date (If Appropriate)	

## U. S. Patent Application Publications

Examiner Initial	Ref	Document Number	Date	Name	Class	Subclass	Filing Date (If Appropriate)	

## Foreign Patent Documents

Examiner Initial	Ref	Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
		05-335016	12/17/93	JAPAN			ABS	
		09-171814	06/30/97	JAPAN			ABS	

## Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)

		Notification of Reasons for Refusal dated February 15, 2010 with an English translation.

Examiner

Date Considered

Examiner: Initial if citation considered, whether citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.